



2100 Pennsylvania Avenue, NW
Washington, DC 20037-3213
T 202.293.7060
F 202.293.7860

www.sughrue.com

April 2, 2004

MAIL STOP PATENT APPLICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450



Re: Application of Noriaki OKAZAWA, Munehide KANAYA and Tsuyoshi KITAHARA
PIEZOELECTRIC ELEMENT FORMATION MEMBER, METHOD OF
MANUFACTURING THE SAME, PIEZOELECTRIC ACTUATOR UNIT AND
LIQUID EJECTION HEAD INCORPORATING THE SAME
Assignee: **SEIKO EPSON CORPORATION**
Our Ref. Q80885

Dear Sir:

Attached hereto is the application identified above comprising twenty-seven (27) sheets of the specification, including the claims and abstract and ten (10) sheets of drawings. **The requisite U.S. Government Filing Fee, copies of the executed Declaration and Power of Attorney and Assignment will be submitted at a later date. Also enclosed is an Information Disclosure Statement and PTO/SB/O8 A & B (modified).**

The Government filing fee is calculated as follows:

Total claims	14 - 20	=		x	\$18.00	=	\$0.00
Independent claims	2 - 3	=		x	\$86.00	=	\$0.00
Base Fee							\$770.00
TOTAL FEE							\$770.00

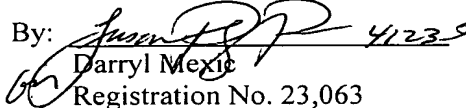
Priority is claimed from:

<u>Country</u>	<u>Application No</u>	<u>Filing Date</u>
Japan	2003-101874	April 4, 2003

The priority document will be filed at a later date.

Respectfully submitted,
SUGHRUE MION, PLLC

Attorneys for Applicant

By:  4/23/04
Darryl Mexie
Registration No. 23,063

SUGHRUE MION, PLLC
Telephone: (202) 293-7060
Facsimile: (202) 293-7860

WASHINGTON OFFICE
23373
CUSTOMER NUMBER